**PRESS RELEASE**  
  
for immediate release

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**EMVA Young Professional Award 2022 – Call for Application**

**Prestigious industry award with prize money, presentation at EMVA Business Conference in Brussels and free pass for European Machine Vision Forum 2022**

*Barcelona, 30 November, 2021*. It is the goal of the European Machine Vision Association to support further innovation in our industry, to contribute to the important aspect of dedicated machine vision education, and to provide a bridge between research and industry. The EMVA Young Professional Award is an annual award endowed with 1500 Euros to honor the outstanding and innovative work of a student or a young professional in the field of machine vision or image processing.

Applicants for the EMVA Young Professional Award are hereby invited to submit their work. Among all papers the EMVA Board of Directors, representing the European Machine Vision Industry, will select the winner of the award. The criteria of the works to be presented are:

* Outstanding or innovative work in the field of vision technology. Industrial relevance and collaboration with a company during the work is required. The targeted industry is free of choice.
* The work (master thesis or PHD thesis or equivalent level research) must have been undertaken within the last 18 months at, or in collaboration with, a European institution. Meanwhile the student may have entered the professional field.

Applicants may submit the following materials to the EMVA President, Dr Chris Yates, at [ypa@emva.org](mailto:ypa@emva.org) latest **until March 31st, 2022**:

* A two-page abstract summarizing the innovation and the intended commercial benefit.
* A one-page CV.
* A copy of the master thesis or PhD thesis. If not yet finished or under publication restrictions, please provide at least one accepted publication.

With the award, the EMVA would like to specifically encourage students and young scientists to focus on challenges in the field of machine vision and to apply latest research results and findings in computer vision to the practical needs of our industry.

The winner of the award will be announced at the flagship 20th EMVA Business Conference 2022 taking place May 12th – 14th in Brussels, Belgium, and will have the opportunity to present the awarded work to the machine vision industry leaders from Europe and abroad. The presentation may then be published by the international machine vision press. In addition to the honor of the EMVA Young Professional Award endowed with 1500 Euros and the publicity for the research work is a free conference pass for the EMVA Business Conference as well as the coverage of all travel cost to Brussels and a free pass for the 2022 European Machine Vision Forum in Ireland.

More information at [www.emva.org/news/emva-young-professional-award-2022-call-for-application/](http://www.emva.org/news/emva-young-professional-award-2022-call-for-application/).

**About EMVA**

The European Machine Vision Association is a non-for-profit and non-commercial association representing the Machine Vision industry in Europe. The association was founded in 2003 to promote the development and use of vision technology in all sectors, and represents members from within Europe, North America, and Asia. The EMVA is open for all types of organizations having a stake in machine vision, computer vision, embedded vision or imaging technologies: manufacturers, system and machine builders, integrators, distributors, consultancies, research organizations and academia. All members – as the 100% owners of the association – benefit from the networking, cooperation, standardization, and the numerous and diverse activities of the EMVA. The EMVA is the host of four global machine vision standards: The two widely established standards GenICam and EMVA 1288 as well as the two standardization initiatives Open Optics Camera Interface (OOCI) and Embedded Vision Interface Standard (emVision).